



Docket No.: 50099-180

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shigenobu MAEDA, et al.

Application No.: 09/988,593

Filed: November 20, 2001

For: SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER ISOLATION
REGION (As Amended)

: **RESPONSE UNDER 37 CFR 1.116**
: **EXPEDITED PROCEDURE**

: Group Art Unit: 2823

: Examiner: T. Pham

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Final Office Action dated April 10, 2003, pursuant to the provisions of 37 C.F.R. § 1.116. The claims are presented in the revised amendment format described in the Official Gazette,¹ regarding waiver of the current provisions of 37 C.F.R. §§ 1.121(a)-1.121(d).

¹ 1267 Off. Gaz. Pat. Office 4 (February 25, 2003).

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